071469-0308624

# Client Reference: ES-039

#### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

HONGYU YUE, ASAO YAMASHITA

Application No.:

Confirmation

No:

Filed:

March 31, 2004

Group No.:

Examiner

For:

System and Method for Etching a Mask

**Commissioner for Patents** P.O. Box 1450 Alexandria, VA 22313-1450

## SUPPLEMENTAL APPLICATION DATA SHEET 37 C.F.R. § 1.76

#### **BIBLIOGRAPHIC DATA**

#### 1. Applicant information

First applicant: HONGYU YUE

Citizenship: PEOPLE'S REPUBLIC OF CHINA

Residence: Austin, TX 78479

Second applicant: ASAO YAMASHITA

Citizenship: JAPAN

Residence: Wappingers Falls, NY 12590

#### 2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

#### 3. Application information

Title of Invention: System and Method for Etching a Mask

Docket number assigned to this application: 071469-0308624

Suggested Classification:

Class:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 15

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

Application Date Sheet--page 1 of 2

**PATENT** 

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

# 4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

## 5. Assignee information

The assignee(s) of this application is/are:

Tokyo Electron Limited 3-6, Akasaka 5-chome, Minato-ku Tokyo, 107 JAPAN Extent of interest of assignee in application: 100%

Date: June 21, 2004

PILLSBURY WINTHROP LLP P.O. Box 10500 McLean, VA 22102 Customer No. 00909 Jeffrey D. Karceski Registration No. 35914 (703) 905-2110